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# REVIEW



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# Strategies for suppressing dark current of perovskite photodiodes towards reliable optoelectronic applications

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Photodetection is crucial for advancements in next-generation technologies, including Internet of Things, intelligent perception, augmented and virtual reality, and human–machine interactions. Metal halide perovskites (MHPs) show unique properties that allow for the creation of straightforward diode structures, enabling efficient photogeneration and charge collection across a broad spectrum of wavelengths, from ionizing radiation to near-infrared. However, the presence of dark current  $(I_{d})$  poses a significant challenge, affecting the performance of these devices. This review commences by outlining the essential performance measures impacted either directly or indirectly by  $I<sub>d</sub>$ . Subsequently, it investigates the adjustable MHP materials employed in photodiodes, with a focus on their structural and morphological characteristics. We then explore the origins of  $I_d$  and highlight the crucial factors that impact the performance of MHP-based photodiodes (MHPPDs). Additionally, we examine various strategies to mitigate  $I<sub>dr</sub>$ , thereby improving device efficacy. Finally, we provide insights into future directions for reducing  $I_d$  in MHPPDs, potentially leading to further enhancements in photodetection technologies. **PUEW**<br> **Published on 2024. 22.1075**<br>
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## 1. Introduction

Photodetection is crucial in diverse fields, including medical Xray imaging, visible light capture, near-infrared medical imaging, short-wave infrared surveillance, and machine vision. $1,2$ These applications fundamentally depend on semiconductor photodetectors to transduce photons into electrical signals for processing, image reconstruction, and storage. Commonly, photodiodes and phototransistors constructed from inorganic semiconductors of silicon or III–V compounds, when integrated with thin-film transistors (TFTs) or complementary metal oxide semiconductors (CMOS) within a backplane architecture, enable the creation of intricate image sensor arrays suitable for modern optoelectronics.3,4

The escalating demands of Internet of Things, intelligent perception, augmented and virtual reality, and human– machine interactions necessitate components that are lightweight, energy-efficient, miniature, and mechanically flexible.<sup>5</sup> In response, researchers are exploring diverse semiconductorbased photodetectors,  $6,7$  including organic materials, inorganic nanocrystals (NCs), quantum dots (QDs), and metal–halide perovskites (MHPs). MHPs, in particular, have attracted substantial attention due to their remarkable capabilities. These materials offer an ultra-broad spectral photodetection range, from ionizing radiation to near-infrared, achievable through

tailored adjustments in their organic and inorganic compositions. MHPs are not only derived from abundant resources and require low deposition temperatures but also form efficient single layers owing to their low exciton binding energy.<sup>8</sup> When integrated into optoelectronic systems, they substantively augment functionality and precision in various sensing applications, such as photoplethysmography (PPG) sensors and pulse oximeters, enabling real-time and non-invasive monitoring.

While MHP-based photoconductors and phototransistors are notable for their impressive responsivity, facilitating signal amplification across applications, they tend to have slower response times and usually require additional biasing circuits for optimal performance. These factors demand careful consideration, particularly in the context of specific applications. Despite these challenges, the intrinsic properties of MHPs support the creation of simplified diode architectures that promote efficient photogeneration and charge collection with minimal losses. MHPPDs, employing configurations such as P– N, P–I–N, or Schottky junctions, can function without an external power supply. Applying an additional reverse bias can further enhance the efficiency of photogenerated carrier collection.<sup>9</sup> Moreover, the progress in MHP-based devices benefits extensively from ongoing research on perovskite photovoltaics. Consequently, significant research efforts are directed at advancing our understanding of materials, device architectures, physical mechanisms, and processing techniques in this field. This endeavor seeks to improve the figures of merits (FOMs) of MHPPDs to bring them on par with those of their counterparts.

A critical parameter affecting MHPPDs' FOMs directly or indirectly, including the on–off ratio (OOR), linear dynamic range (LDR), specific detectivity  $(D^*)$ , is the dark current  $(I_d)$ . In MHPPDs, as illustrated in Fig. 1, carriers in an MHP film tend to drift towards their respective electrodes in the absence of a bias voltage. This behavior, facilitated by the unique properties

of MHPs, leads to complete depletion even without an applied bias voltage, significantly impacting the device's performance. The OOR is defined as the ratio of the photocurrent generated when the photodiode is exposed to light (on-state) to  $I_d$  when it is not exposed to light (off-state). This ratio indicates how effectively a photodiode can distinguish between the presence and absence of light signals. Therefore, reducing  $I<sub>d</sub>$  in MHPPDs while preserving the photocurrent can considerably enhance the OOR. The LDR represents a valuable feature for MHPPDs where the output, such as photocurrent or responsivity, remains stable across a broad spectrum of incident light intensities. Beyond this dynamic range, the light signals cannot be accurately detected due to the elevated levels of  $I_d$ .<sup>10</sup> Additionally, the noise equivalent power (NEP) defines the minimum optical power a photodiode can differentiate from the noise current, indicating the sensitivity of the photodiode to weak light signals. Noise current  $(i_n)$  in units of A  $\text{Hz}^{-1/2}$ primarily includes shot noise, thermal noise, and flicker noise, among which shot noise, arising from the discrete passage of electrons and holes, generally dominates. Thermal noise is linked to the random motion of charge carriers, and flicker noise can result from fluctuations in conductivity due to variations in the electron concentration. $11$  Additionally, the influence of  $I_d$  in the practical industrial applications of photodiodes is substantial. For example, high  $I_d$  can rapidly reach the breakdown voltage of TFTs or CMOS, widely employed in imaging and sensing technology, rendering them ineffective.<sup>12</sup> Powisw Journal of Matrics in their organic and inorganic composi- of MHFs, leads to complete depletion even without an applied ito solid deviated from aluminar treatons and bias volume in the solid state in the solid devia

Furthermore, the  $I_d$  of MHPPDs plays a crucial role in direct radiation detection, specifically in X-ray imaging and ionizing radiation detection applications, enabling nondestructive inspection in medical, security, and scientific fields. In direct radiation X-ray detection, MHPPDs employ active layers with thicknesses up to millimeters to effectively block high-energy radiation photons, which raises the issue of less charge



Fig. 1 Schematic illustration of the energy diagram of P–I–N photodiodes without bias (a) and under bias conditions (b). Schematic of the parameters influenced by  $I_d$  in photodiodes for light sensing and direct X-ray detection. (c) On–off ratio (OOR). (d) Noise current  $(i_n)$ . (e) Linear dynamic range (LDR) (f) Detection limit.

collection efficiency for the devices. One effective solution to overcome this challenge is operating MHPPDs at a high reverse bias, which unfortunately leads to a higher  $I_d$ . It can deteriorate the detection limit (refers to the lowest level of X-ray radiation that can be reliably detected) and the dynamic range of the ionizing radiation response of a detector. Furthermore, due to their low defect formation energies, the formed defects within MHPs are prone to ion migration when subjected to an electric field. As a result, the high reverse bias applied to MHPPDs in ionizing radiation applications can trigger a saturation period lasting hours, referred to as  $I<sub>d</sub>$  drift, which affects the current long-term stability of MHPPDs, as these devices are typically operated at a specific reverse bias voltage relative to the

reference  $I_d$ .<sup>13</sup> The  $I_d$  drift can be calculated using:  $D =$ 

 $\frac{I_{\text{fish}} - I_{\text{begin}}}{iE}$ , where  $I_{\text{ finish}}$  and  $I_{\text{begin}}$  are the final and initial dark currents,  $t$  is the test time, and  $E$  is the applied electric field.

Therefore, understanding the fundamental causes of  $I_d$  in MHPPDs is crucial. By exploring the elements that influence  $I_d$ , we can devise effective strategies to mitigate it, thus overcoming the challenges associated with the material composition and device architecture. Although recent literature $14$  provides a thorough examination of  $I_d$ 's origins, limitations, and countermeasures in various MHP-based detectors like photodiodes, photoconductors, and phototransistors, there remains a gap concerning the specific issues of  $I<sub>d</sub>$  in MHPPDs. Considering the significant impact of MHPPDs on the evolution of MHPbased photodetection technologies, further investigation in this area is essential. This review starts by defining the key performance metrics that are directly or indirectly influenced by  $I_d$ . It then examines the tunable MHP materials used in photodiodes, emphasizing their structural and morphological properties. We then explore the sources of  $I_d$  and identify the key factors influencing  $I_d$  in MHPPDs. Additionally, we discuss various tactics to curb  $I_d$  in these devices. Finally, we contemplate future approaches to reduce  $I_d$  in MHPPDs, underlining the necessity of developing a clear understanding of  $I_d$ 's mechanisms and exploring new avenues for research to diminish  $I_d$  effectively. **Journal of Materials Chemistry C**<br> **Sources one effective solution to** reduce it is defined as the miniof of he photoconrest generated by<br>
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## 2. Figures of merits of photodiodes and their relationship with dark current

In the following section, we provide a comprehensive definition of the key performance metrics that are directly or indirectly influenced by  $I_d$ , thereby enabling a clear understanding of the reported MHPPD performances. A schematic illustration of several parameters affected by  $I_d$  is shown in Fig. 1. For the most relevant metrics, we highlight their definitions and mathematical expressions, as well as their relationships with  $I_d$ .

#### 2.1 Signal-to-noise ratio

In photodiodes, the signal-to-noise ratio (SNR) is a measure of the quality of the signal relative to the level of background

noise. It is defined as the ratio of the photocurrent generated by the incident light (signal) to the noise current present in the system. Mathematically, the SNR can be expressed as:

$$
SNR = \frac{i_{ph}}{i_n}
$$

where  $i_{\rm ph}$  is the photocurrent resulting from the incident light, and  $i_n$  is the total noise current. Since  $I_d$  contributes to the shot noise, which is a significant component of the total noise current,  $I_d$  directly affects the noise current and consequently impacts the SNR. A higher  $I_d$  results in increased shot noise, which reduces the SNR. Furthermore, for simplicity, the OOR is often employed to gauge the sensitivity of photodiodes to light signals. It is calculated as the ratio of the photocurrent to the  $I<sub>d</sub>$ .

#### 2.2 Spectral responsivity and EQE

The spectral responsivity  $(R)$  in units of A  $W^{-1}$  describes how much current is generated by a photodiode per incoming photon of a given energy. It can be calculated using the formula:

$$
R = \frac{J_{\rm ph}}{P_{\rm in}}
$$

where  $J_{\text{ph}}$  is the photocurrent density and  $P_{\text{in}}$  is the incident light intensity. EQE, which denotes the ratio between the number of incoming photons and the number of photogenerated free electrons, can be expressed as:

$$
EQE = R \frac{h\theta}{q}
$$

where h is the Planck constant,  $\nu$  is the frequency of the incident photon, and  $q$  is the elementary charge. Generally, a high EQE (and hence  $R$ ) is desirable to ensure efficient photon flux detection. In most cases, the EQE (or  $R$ ) and  $I_d$  are considered independent parameters. However, it is important to note that a high  $I_d$  can lead to increased shot noise. This noise degrades the overall performance of the photodiode by making it more challenging to detect low-intensity signals accurately. This degradation can indirectly affect the effective EQE or  $(R)$  as well.

#### 2.3 Speed

The speed of response, defined as the time required to collect photogenerated charge carriers at their respective contacts, ultimately determines the photodiode's dynamic range and cut-off frequency. Generally, the speed is evaluated based on the rise time  $(t_r)$  (the time it takes for the device response to increase from 10% to 90%) and the fall time  $(t_f)$  (the time it takes for the device response to decrease from 90% to 10%). The speed of response and  $I_d$  are both dependent on the intrinsic properties of the semiconductor materials, photodiode junction capacitance, and device operating temperature. For instance, high-quality semiconductors with fewer defects typically exhibit lower  $I<sub>d</sub>$  and can also support faster response speeds. Conversely, high  $I_d$  can imply higher leakage in the junction, which may increase the junction capacitance.

Increased capacitance can slow down the response speed, as the photodiode takes longer to charge and discharge.

#### 2.4 Noise equivalent power and specific detectivity  $(D^*)$

The minimum incident light power that can be detected by a photodiode is referred to as the noise equivalent power (NEP). NEP is defined as the signal optical power that yields a SNR of 1. The NEP, expressed in units of W  $Hz^{-1/2}$ , can be calculated using the formula:

$$
NEP = \frac{i_n}{R\sqrt{B}}
$$

where  $i_n$  is the noise current and B is the detection bandwidth. The specific detectivity  $D^*$  in units of cm  $\mathrm{Hz}^{1/2} \mathrm{W}^{-1}$  (or Jones) is the reciprocal of the NEP normalized to the square root of the device area A:

$$
D^* = \frac{R\sqrt{AB}}{i_n}
$$

As discussed,  $i_n$  primarily comprises shot noise, thermal noise, and flicker noise. Experimental measurements of  $i_n$  are challenging and not always performed. For simplicity, it is often assumed that the shot noise  $(i<sub>shot</sub>)$  from the  $I<sub>d</sub>$  is the dominant contribution to  $i_n$ :

$$
D^* \cong \frac{R\sqrt{AB}}{i_{\text{shot}}} = \frac{R\sqrt{A}}{\sqrt{2qi_{\text{d}}}}
$$

This assumption implies that the  $I_d$  (or  $i_{shot}$ ) is the primary factor limiting  $D^*$ , while thermal noise and flicker noise are ignored. However, in photodiodes, and particularly in MHPPDs,  $i_n$  is not solely equivalent to  $i_{shot}$ , especially at low frequencies. Thus, this simplification can lead to an overestimation of D\*.

#### 2.5 Linear dynamic range

In photodiodes, the linear dynamic range (LDR) is a specification that indicates the range of incident light intensities over which the photodiode can produce a linear (proportional) response in terms of the output photocurrent. Essentially, it quantifies the operational light intensity span of the image sensor. It is defined as the ratio between the maximum detectable photocurrent before saturation and the minimum detectable photocurrent above the noise floor. Mathematically, the LDR can be expressed in decibels (dB) as:

$$
\text{LDR}=10\log\left(\frac{I_{\text{max}}}{I_{\text{min}}}\right)
$$

where  $I_{\text{max}}$  is the maximum photocurrent that the photodiode can handle linearly, limited by the onset of saturation.  $I_{\min}$  is the minimum photocurrent that can be detected above the noise floor, dominated by the  $I_d$  and other noise sources. A higher  $I_d$  increases the noise floor, thus raising the minimum detectable photocurrent  $I_{\min}$ . Consequently, this reduces the LDR because: as  $I_{\text{min}}$  increases, the ratio  $I_{\text{max}}/I_{\text{min}}$  decreases. This ratio determines the LDR, so an increase in  $I_{\text{min}}$  directly reduces the LDR.

## 3. Metal halide perovskites for photodiodes

Typically, MHPs have the general formula  $ABX_3$ , where A represents monovalent cations such as  $\mathrm{CH_3NH_3}^+$  (MA),  $\mathrm{HC(NH_2)_2}^+$  (FA), cesium (Cs<sup>+</sup>), and rubidium (Rb<sup>+</sup>) or their combinations. B refers to divalent metal cations such as  $Pb^{2+}$ ,  $Sn^{2+}$ ,  $Bi^{2+}$ , and  $Ge^{2+}$ , while X represents halide anions such as  $Cl^-$ ,  $Br^-$ , and  $I^-$  or a combination thereof. By adjusting the components, structure, and morphology, the optical absorption and electrical properties of MHPs can be easily modified. For example, as the ionic radius of the A cation increases  $(r_{Cs}^+$  <  $r_{\text{MA}}^+ < r_{\text{FA}}^+$ ), the lattice expands, and the bandgap decreases, leading to a red shift in the optical absorption band. Another way to tune the bandgap is by replacing  $Pb^{2+}$  with  $Sn^{2+}$ , which reduces the bandgap and extends the optical absorption edge into the near-infrared (NIR) region. Successive tuning of the bandgap of MHPs can also be manipulated by changing the halide composition. As shown in Fig. 2a, the halide composition changes from  $Cl^-$  to  $Br^-$  to  $I^-$ , and the bandgap sequentially decreases, allowing MHPs to absorb a broader range of light from ultraviolet (UV) to visible wavelengths.<sup>15</sup> Furthermore, MHPs composed of Pb, Bi, I, and Br are promising for direct radiation detection due to the high atomic number of these elements, providing excellent potential for quick X-ray direct detection.<sup>16</sup> Peview Journal of Materials can siaw down the response speed, as **3.** Metal haldele perovskites for the phosiole task only revealed online of the control of the properties change and disk<br>of the probability of the propert

The structure dimensionality of MHPs can be tuned from three-dimensional (3D) bulk materials to two-dimensional (2D) layered structures and one-dimensional (1D) chain materials by manipulating the connections of  $[BX_6]^{4-}$  octahedral units (as shown in Fig. 2b). For instance, 2D MHPs are formed by incorporating larger organic cation layers between the octahedral network of 3D MHPs. This can be expressed as a general formula  $(LA)<sub>m</sub>(A)<sub>n-1</sub>B<sub>n</sub>X<sub>3n+1</sub>$ , where LA represents the larger organic cation and  $n$  denotes the number of layers in the 2D MHP structure. Introducing these larger organic cations in lowdimensional MHPs enhances their moisture stability and mechanical flexibility compared to their 3D counterparts. However, it should be noted that these long-chain organic cations also decrease the dielectric constant of MHPs, leading to an increase in the exciton binding energy. Consequently, the efficient separation and extraction of photogenerated carriers can be impeded.<sup>19</sup>

Moreover, the control over the morphology dimensionality of MHPs enables the incorporation of novel properties into these materials.<sup>20</sup> (Fig. 2b) For instance, 0D MHP nanostructures such as NCs and QDs exhibit tunable sizes ranging from several to tens of nanometers. These nanostructures generally possess large extinction coefficients and demonstrate characteristics of multiple-exciton generation. On the other hand, 1D MHP micro/nanostructures, including nanowires (NWs) and nanorods (NRs), feature significant surface-to-volume ratios and anisotropic geometries. These attributes contribute to low defect/trap densities, prolonged charge-carrier lifetimes, and reduced carrier recombination rates. Furthermore, 2D MHPs, comprising nanoplates, nanoflakes, and nanosheets,



Fig. 2 (a) Bandgaps of MHPs (CsPbBr<sub>3</sub> nanocrystals) can be tuned by changing halide components. Reproduced with permission.<sup>17</sup> Copyright 2015, ACS. (b) Optical and electrical properties can be tuned by the tunable dimensionality at the structural and morphological level of MHPs. Reproduced with permission.<sup>18</sup> Copyright 2021, ACS.

exhibit strong quantum confinement effects and possess unique morphological characteristics. Additionally, these lowdimensional MHP materials demonstrate reasonable mechanical flexibility due to their atomic thickness. However, the nanostructures of low-dimensional MHPs still encounter issues that hinder charge transport and extraction in photodiodes. For instance, an excess of long-chain organic ligands on the surfaces of 0D and 2D MHPs can obstruct carrier transport, leading to reduced charge transfer efficiency. Moreover, the random orientation and rough morphology of 1D and 2D MHPs may create leakage paths, further impeding charge extraction. While 3D MHP polycrystalline materials have demonstrated remarkable improvements in photovoltaics due to their superior optoelectronic properties, overcoming challenges related to hysteresis and stability remains an ongoing endeavor. $^{21}$ 

## 4. The origin of dark current in MHPPDs

### 4.1 Understanding dark current in MHPPDs

Typically, photodiodes are operated under reverse bias, so  $I_d$  is also known as reverse saturation current. In the following part, dark current density  $(J_d)$  is investigated by considering the device area in a photodiode. In photodiodes,  $J_d$  flow of majority carriers can be impeded by the interfacial barrier of P–N junctions. Thus,  $J_d$  in MHPPDs comprises several components: diffusion current  $(J_{\text{diff}})$ , influenced by thermodynamics; generation-recombination current  $(J<sub>g-r</sub>)$ , determined by various recombination processes such as trap-assisted recombination, Auger recombination, and radiative recombination; and tunneling current (trap assisted tunneling, TAT) and leakage current, influenced by traps present in the absorption layer and at the interface between the absorber materials or electrodes and subsequent transport layers, as shown in Fig. 3.

According to the following equation,  $J_{\text{diff}}$  of a semiconductor-based photodiode is determined by thermodynamics, such as the carrier density and bandgap of the materials used:

$$
J_{\rm diff} = q N_{\rm c} N_{\rm v} \Bigg( \frac{1}{N_{\rm A}} \sqrt{\frac{D_{\rm n}}{\tau_{\rm n}}} + \frac{1}{N_{\rm D}} \sqrt{\frac{D_{\rm p}}{\tau_{\rm p}}} \Bigg) \exp \bigg( - \frac{E_{\rm g}}{k_{\rm B} T} \bigg)
$$

where  $D_p$  and  $D_n$  are the diffusion coefficients of holes and



Fig. 3 The typical components and generation mechanisms of dark current in MHPPDs.

electrons, respectively.  $N_D$  and  $N_A$  represent the donor and acceptor concentrations on the n side and p side, respectively.  $N_c$  and  $N_v$  denote the effective density of states for electrons in the conduction band and holes in the valence band, respectively;  $\tau_p$  and  $\tau_n$  are the carrier lifetimes of holes and electrons, respectively.  $J_{diff}$  in a photodiode increases with temperature and decreases as the material quality increases.

The type of contact can influence  $J_{\text{diff}}$ . In the case of a Schottky contact, where the depletion region serves as the barrier layer,  $J_{\text{diff}}$  consists of various components. One of these components is the thermionic-emission current  $(J_T)$ , which can be calculated using the Richardson–Dushman equation based on the thermionic-emission theory. This equation helps determine the contribution of thermionic emission to the overall  $J_{\rm diff}$ : $^{22}$ 

$$
J_{\rm T} = A T^2 e^{-\frac{q\varphi_{\rm s}}{kT}} \left( \frac{qV}{e^{kT}} - 1 \right)
$$

The Richardson constant, denoted by A, has a value of 120 A  $\rm (cm^{-2}~K^{-2})$  for vacuum. It reflects the relationship between the temperature, area, and the thermionic-emission current. The term  $q\varphi_s$  represents the barrier height for carrier injection in the Schottky contact. Any changes in the Schottky barrier height  $(\varphi_s)$  affect  $J_T$ , the main contributor to  $J_{\text{diff}}$  in this contact configuration. On the other hand, in the case of an Ohmic contact where the depletion region acts as the accumulation layer,  $J<sub>diff</sub>$  arises from a combination of carrier thermionicemission and diffusion processes. Theoretically, introducing blocking layers with high enough barriers between materials and electrodes makes achieving low  $J_{\text{diff}}$  in the P–N junction possible.

Another significant source of  $J_d$  is the generationrecombination current  $(J_{g-r})$ , which arises from both the bulk depletion region and the interface. According to the Shockley– Read–Hall (SRH) model,  $J_{g-r}$  is determined in the bulk layer:<sup>23</sup>

$$
J_{g-r} = \frac{qn_i X_d}{2\tau} \left(e^{\frac{qV}{2kT}} - 1\right)
$$

in addition to the factors mentioned earlier,  $J_{\mathrm{g-r}}$  depends on the intrinsic carrier concentration  $(n<sub>i</sub>)$  and the non-equilibrium carrier lifetime  $(\tau)$ , which is inversely related to the trap concentration  $(N_{\rm t})$ .  $J_{\rm g-r}$  is directly proportional to both  $N_{\rm t}$  and the depletion region width  $(X_{\mathrm{d}})$ . Unlike  $J_{\mathrm{T}},~J_{\mathrm{g-r}}$  cannot be suppressed by the Schottky barrier alone. However, by reducing the concentration of traps in the semiconductor material,  $J_{\mathrm{g-r}}$ can be effectively suppressed. This highlights the importance of minimizing trap concentrations to achieve low  $J<sub>d</sub>$ .

Aside from charge injection and bulk thermal generation of charge carriers, tunneling and leakage current processes also affect  $J_d$  in photodiodes. Photodiodes typically consist of multiple layers, including an absorber and a charge transport layer. Suppose traps are present in the absorber layer, in that case, trap-assisted tunneling can occur between the valence and conduction bands of the absorber materials or between the absorber materials and subsequent transport layers, increasing  $J_d$ .

#### 4.2 Advancements in exploring dark current mechanisms in MHPPDs

In the context of MHPPDs, investigating the factors that influence  $J_d$  is essential for elucidating its origin. Researchers have identified that one of the primary origins of  $J_d$  in MHPPDs is the migration of ions through the bulk of the grains via point defects or extended defects, such as grain boundaries, which are considered material imperfections specific to MHPPDs. A study conducted by Jang et al. compared MHPPDs based on Pb and Sn MHP films. The researchers discovered that vertical grain boundaries in these materials contribute to increased  $J<sub>d</sub>$ , while horizontal grain boundaries have the opposite effect of reducing ${J_{\rm d}}^{24}$  This disparity can be attributed to smaller grains in the Sn-based MHPs, resulting in divergent shunt pathways for  $J<sub>d</sub>$ . (Fig. 4a) Consequently, Yang et al. conducted a study in which they observed a decrease in the  $J<sub>d</sub>$  of MHP films containing potassium salt additives by reducing the crystal grain size of Sn-based MHPs. This reduction in  $J_d$  was attributed to the increased presence of shunting paths. $25$  Furthermore, the inherently weaker halide-ion migration in the Sn-based material provides an advantage in suppressing  $J<sub>d</sub>$ . Similarly, Dey et al. conducted an investigation using scan-rate-dependent hysteresis analyses, temperature-dependent impedance spectroscopy measurements, and first-principles calculations

on mixed Pb-Sn MHPs.<sup>26</sup> Their research revealed the crucial role of Sn vacancies in enhancing the migration barrier of iodide ions, which occurs due to local structural distortions. Yin et al. conducted a study highlighting the significant contribution of surface iodine vacancies to  $J_d$  in polycrystalline MHPPDs.<sup>27</sup> Their experimental findings revealed that the trap states induced by surface iodine vacancies within the bandgap can create many generation and recombination centers. Consequently, this leads to a decrease in the minority carrier lifetime and an increase in the generation–recombination current density based on the SRH mechanisms under dark conditions (Fig. 4b). Moreover, Moseley et al. underscored the significance of considering the presence of defects in MHP films, which can result in  $J_d$  that exhibit time-dependent drifting over seconds, as they can cause measurement challenges such as speed and LDR.<sup>28</sup> These defects and trap states can generate a photoconductive gain by extending carrier lifetimes beyond transit times or altering interface energetics, enabling charge injection even under low light intensity in MHPPDs. Power Sources continues are of an Ohmic on mixed Pb-5s MHFs<sup>26</sup> Encorable of Machematics contents where the episode on the contents of the symphometic in the discussion in the discussion in the discussion of the symphomet

In addition to the presence of structural and compositional imperfections such as pinholes, trap states, and grain boundary leakage in MHPs, the contact between the MHPs and the charge transport layers (CTLs) or electrodes also significantly influences the experimental  $J_d$  of MHPPDs. Sutherland et al. observed that MHPPDs and MHP-based solar cells exhibit differences in their reverse saturation current density. $31$  Given

that 
$$
V_{\text{oc}} = nKTq^{-1} \ln \left[ \frac{\left( J_{\text{sc}} - \frac{V_{\text{oc}}}{R_{\text{sh}}} \right)}{J_0} + 1 \right]
$$
, shunt paths are not

crucial in limiting  $V_{\text{oc}}$  (open-circuit voltage) until  $R_{\text{sh}}$  (shunt resistance) becomes extremely small. Shunt paths of this magnitude can immensely increase  $J_d$  under reverse bias. Thus, it is not always guaranteed that the efforts to optimize solar cell performance will result in sufficiently low  $J<sub>d</sub>$  for effective photodetection. They further developed the electron contact composites (TiO<sub>2</sub>/Al<sub>2</sub>O<sub>3</sub>/PCBM) for MHPPDs to minimize  $J_d$ . Duijnstee et al. discovered that the experimental data must consider an interface injection barrier to fit the TPC measurement.<sup>32</sup> They pointed out that the injection barrier and ionization of trapped carriers at the interface contribute to the  $J<sub>d</sub>$ . Moreover, Ollearo et al. demonstrated that the interfacial energy offset between the electron-blocking layers and the MHPs significantly determines the magnitude of  $J_d$ .<sup>29</sup> As the offset increases, it can efficiently suppress the thermal charge generation at the interface between electron-blocking layers (EBL) and the MHPs, leading to a significantly lower  $J_d$ (Fig. 4c).

#### 4.3 The dark current drift in MHPPDs

The  $J_d$ 's saturation period under reverse bias conditions commonly known as instabilities in the dark reverse saturation current can lead to measurement inaccuracy in MHPPDs, especially for direct radiation detection. It is worth mentioning that other halide-based radiation detectors under the high



Fig. 4 (a) Diagram illustrating the formation of multiple divergent leakage pathways in a Sn-based MHP with a reduced grain size. Reproduced with permission.<sup>24</sup> Copyright 2022, Wiley-VCH. (b) Schematic energy level diagram showing the generation–recombination processes enhanced by surface trap states under dark conditions. Reproduced with permission.<sup>27</sup> Copyright 2023, Wiley-VCH. (c) Schematic representation of the thermal charge generation mechanism at the EBL-MHP interface. Reproduced with permission.<sup>29</sup> Copyright 2021, Nature. (d) Schematic regime of long-term dark reverse bias current response for MHPPDs. Reproduced with permission.<sup>30</sup> Copyright 2022, Wiley-VCH.

reverse bias conditions also face the problem of  $J_d$  drift.<sup>33</sup> Recent studies have highlighted two leading causes for the  $J<sub>d</sub>$ drift in MHP films used in direct radiation detection. Firstly, the presence of mobile ions within the bulk and grain boundaries of MHP films can contribute to the drift.<sup>34</sup> Secondly, the trapping or accumulating charge carriers at interlayers can also lead to the drift phenomenon. Several techniques and models have been employed to investigate and predict the transient  $J_d$ decay characteristics associated with the trapping or accumulating charge carriers at interlayers. Different MHP absorbers and interlayer materials have been studied in this regard.<sup>35-37</sup>

Understanding the ionic conduction in MHPs, in terms of electronic and ionic behaviors, is crucial in comprehending the  $J<sub>d</sub>$  drift regarding ion migration process. Yang et al. studied  $MA_{1-x}FA_xPbI_3$ , a mixed electronic/ionic material, they discovered that halide (iodine) migration occurs under an electric field in such materials by measuring and modeling the stoichiometric polarization by the mixed conduction.<sup>38</sup> Investigating ion mobility in different MHPs is significant due to their known halide ion-conducting properties under dark conditions. García-Batlle et al. conducted a comparative analysis of two compounds, namely  $MAPbBr<sub>3</sub>$  and  $MAPbI<sub>3</sub>$ , along with different structures, such as single-crystalline and microcrystalline, to study the long-term evolution of  $J_d$ .<sup>39</sup> To estimate the ion mobility in these systems, they employed ionic time-of-

flight measurement techniques and obtained values ranging from  $10^{-7}$  to  $10^{-6}$  cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup>. The results revealed that bromide compounds exhibited lower ion mobility, dependent on the electric field. Conversely, iodide compounds showed higher ion mobility, independent of the electric field. In addition, Almora et al. performed MATLAB code driftfusion simulations to investigate the long-term reverse bias current behavior in MHPPDs.<sup>30</sup> (Fig. 4d) Their findings revealed that the steadystate  $J_d$  observed under reverse bias is primarily an electronic current rather than an ionic current, even though the presence and concentration of mobile ions play a crucial role. The reduction of  $J_d$  drift through screening is influenced by the following factors: the thickness of the MHPs, the applied electric field, the concentration of mobile ions, and the mobile ion mobility. By employing material engineering techniques such as composition and interface engineering in MHPs, it is possible to reduce the screening of  $J<sub>d</sub>$  drift.

## 5. Strategies for suppressing dark current toward high performance MHPPDs

Comprehending the components and underlying mechanisms of  $J_d$  in photodiodes is crucial for understanding their operational behavior. This knowledge facilitates the development of



Fig. 5 Schematic illustration of the components of  $J_d$  and the methods for suppressing the  $J_d$  of MHPPDs.

targeted strategies to mitigate  $J<sub>d</sub>$  in MHPPDs. For instance, operating these devices at lower temperatures can effectively reduce the intrinsic carrier concentration within the MHP film, which serves to suppress  $J_{\text{diff}}$ . Additionally, employing techniques such as compositional modulation and bulk passivation can enhance the MHP film quality and reduce inherent material defects, thereby diminishing  $\jmath_{\rm g-r}$ . Furthermore, employing interfacial engineering strategies, including the use of insertion layers or passivation techniques, can crucially curb surface or interfacial defects. This, in turn, helps to decrease  $J<sub>d</sub>$  associated with trap-induced carrier generation and recombination. The application of heterojunctions allows for the integration of MHP with other materials, promoting optimal band alignment, reducing surface defects, and tuning related optical and electrical properties. Such alignment, aided by the built-in potential, acts as a barrier against the flow of majority carriers to decrease  $J_{\text{diff}}$ . Moreover, modifications in device architecture can influence carrier transport mechanisms and promote band bending, which further prevents carrier recombination. In the following section, we delineate comprehensive strategies for mitigating  $J_d$  in both the material composition and device structure to boost performance and ensure the reliability of optoelectronic applications, as shown in Fig. 5.

#### 5.1 Component modulation

As ionic crystals, MHPs exhibit formation energies for anion/ cation vacancies that are largely influenced by Coulomb

interactions between the ions and crystal frameworks. By precisely controlling the composition of MHP crystals, it becomes feasible to enhance bonding energy, alleviate stress, optimize morphology and crystallinity, and significantly decrease  $J<sub>d</sub>$ .

For instance, as shown in Fig. 6(a)–(c), Yun et al. investigated the engineering of A-site monovalent cations in wide-bandgap MHPs for high-performance blue photodetection.<sup>40</sup> Their findings revealed that introducing FA in MA increased the heat of formation, leading to modulated nucleation and grain growth behavior. Furthermore, the incorporation of optimal Cs (5%) helped mitigate strain and decrease trap states in the MHP thin film, resulting in a more compact and better-arranged crystal lattice. These improvements enabled the fabrication of N–I–P devices with a decent  $D^*$  of 5.08  $\times$  10<sup>12</sup> Jones, and demonstrated the feasibility of individual  $7 \times 7$  devices for real image sensing under 450 nm blue light illumination. Additionally, Liu et al. explored the modulation of A-site monovalent cations and X-site halide anions in MHPPDs for direct X-ray detection.<sup>41</sup> They observed that smaller cations  $(MA^+$  and  $Cs^+)$  and anions (Br-) resulted in the release of lattice stress and improved morphology, as evidenced in Fig. 6d. The optimized composition of  $FA_{0.85}MA_{0.1}Cs_{0.05}PbI_{2.55}Br_{0.45}$  exhibited superior properties, including an ultra-low trap density of  $(4.6 \pm 2.4)$  ×  $10^{9}$  cm<sup>-3</sup>, a long carrier lifetime of 6.4  $\mu$ s, and a diffusion length of 68.9 µm. This composition achieved an extremely low  $J_{\rm d}$  of  $-1.44$  µA cm<sup>-2</sup> at  $-75$  V bias, and a low detection limit of 42 nGy<sub>air</sub> s<sup>-1</sup>. Furlan *et al.* demonstrated the tunable halide



Fig. 6 (a)  $J_d$ , and photocurrent density, and on/off ratio with the different FA/MA ratios. (b) Strain components of control and Cs-incorporating MHP films. (c) Trap density and mobility of control and Cs-incorporating MHP films obtained from the electron/hole-only configuration. Reproduced with permission.<sup>40</sup> Copyright 2022, Wiley-VCH. (d) Schematic illustration of the lattice stress release of the 3-cation mixed-halide FAMACs MHPs. Reproduced with permission.<sup>41</sup> Copyright 2020, Wiley-VCH. (e) The relationship between  $J_d$  and  $V_{oc}$  with various halide Br and I ratios. (f) Surface morphology of  $\mathsf{MAPb}(\mathsf{l}_{1-x}\mathsf{Br}_x)$ 3 MHP thin films obtained by scanning electron microscopy. Reproduced with permission.<sup>42</sup> Copyright 2022, Wiley-VCH. (g) and (h) XRD patterns and PL spectra of the Cs<sub>x</sub>DMA<sub>1-x</sub>PbI<sub>3</sub> films. (i) J–V curves of MHPPDs in the dark based on the Cs<sub>x</sub>DMA<sub>1-x</sub>PbI<sub>3</sub> films. Reproduced with permission.<sup>43</sup> Copyright 2020, Elsevier.

composition in organic cation-based MHPs.<sup>42</sup> By adding Br to  $MAPbI<sub>3</sub>$ -based MHPs, they not only adjusted the bandgap through lattice contraction but also reduced non-radiative recombination losses in MHP layers by tuning the crystallite size, as shown in Fig. 6f. They established a correlation between the reduced  $J_{\rm d}$  (1.3  $\times$  10 $^{-9}$  A cm $^{-2}$  at  $-$ 0.5 V),  $V_{\rm oc}$  enhancements (Fig. 6e), and achieved high-performance MHPPDs ( $D^*$  of 8.7  $\times$  $10^{12}$  Jones) within the range of 350-850 nm. Although inorganic MHPs  $(CsPbX_3)$  are suitable for high-performance and stable photodetection applications, they also exhibit thermodynamic instability at room temperature and spontaneously transform into a photo-inactive phase under ambient conditions due to the small tolerance factor. Li et al. demonstrated high-performance MHPPDs with an ultra-low  $J_d$  (6.4  $\times$  $10^{-5}$  mA cm<sup>-2</sup>) (Fig. 6i) and a high speed of 558 ns by utilizing the organic cation DMA  $(DMA<sup>+</sup> = dimethylammonium,$  $(CH_3)_2NH_2^+$ ) to enhance the room-temperature phase stability of Cs-based MHP thin films.<sup>43</sup> The blue shift of the diffraction peak position observed in Fig. 6g was attributed to the introduction of DMA<sup>+</sup>, which has a larger ionic size than Cs<sup>+</sup>. In

addition, this finding was supported by the photoluminescence spectra (PL) of the  $\text{Cs}^+$  and DMA<sup>+</sup>-based MHP films.

In addition to the effective modulation of A-site and X-site components to reduce  $J_d$  and improve device performance, researchers have also been exploring B-site regulation. For instance, hybrid Pb–Sn MHP-based MHPPDs have been investigated to achieve a broad spectral response ranging from 300 nm to 1000 nm, while also reducing  $J<sub>d</sub>$  compared to Pb-based devices, thanks to the reduced trap density.<sup>44</sup> Furthermore, researchers have conducted halide composition modulation to develop nontoxic bismuth MHPs.<sup>45</sup> All of these demonstrations highlight the significant potential of component modulation in MHPs for effectively suppressing  $J<sub>d</sub>$  and enhancing device performance. An update on the progress in the reported component modulation of the MHPPDs is provided in Table 1.

#### 5.2 Dimensional engineering

Numerous studies have shown that effective dimensional regulation of MHPPDs using hydrophobic organic cations can reduce the dimension of MHPs and transition them from 3D to quasi-2D structures. This not only helps suppress defects, thanks to the high defect formation energies of quasi-2D MHPs, but also significantly improves their stability. Thus, efforts have focused on creating a quasi-2D MHP layer at the interface, forming a  $2D/3D$  MHP structure.<sup>27,53-55</sup> This

approach leads to fewer trap states at the MHP and electrode interface, consequently improving device performance. However, it is important to note that excessive presence of 2D MHPs at the interface, as well as disordered phase distribution, can impede charge transport due to the insulating effect of the bulkier, long-chain organic spacer cations (as illustrated in Fig. 7a). Recent efforts have therefore aimed at creating uniformly distributed, compact 2D–3D gradient MHPs with an ordered phase distribution along the thin film's longitudinal direction, as this offers enhanced optoelectronic properties, stability, and ideal MHPPD characteristics. For instance, Miao et al. employed the hot-casting method to control the phase distribution of quasi-2D MHP thin films.<sup>56</sup> By comparing the top and bottom PL spectra of different MHP thin films (as shown in Fig. 7b), they studied the effects of substrate temperature on surface morphology and internal phase distribution. The resulting device showed an extremely low  $J_d$  (2.3  $\times$  $10^{-11}$  A cm $^{-2}$ ), large  $D^*$  at 455 nm  $(1.22 \times 10^{14}$  Jones), ultra-fast speed (5.5/4.7  $\mu$ s), and remarkable stability. Additionally, Peng et al. reported an ion-exchange strategy to prepare 2D-3D thick MHP films with uniform morphology, vertically aligned monolithic crystal phases, and reproducibility (as shown in Fig. 7c). $57$ By performing an ion exchange between  $Br^-$  and  $I^-$  halide anions, they achieved a slow crystallization process resulting in a gradient phase distribution of 2D–3D MHP thick films. In situ Peoview Journal of Mateina,<br>
addition, this finding was supported by the photoluminescence approach leads to fewer trap state at MHF and electrons<br>
spectra [PU of 0.42 and DMA classed MTF Emiss. Consideration in methods o

Table 1 Summary of the component modulation in bulk MHPs for suppressing  $J<sub>d</sub>$  and enhancing the FOMs of MHPPDs



 $\textsuperscript{a}$  Noise signal: the noise signal in photodetection is recorded by utilizing a fast Fourier transform signal analyzer combined with a preamplifier to capture the noise current at various frequencies. <sup>b</sup> Detection limit: the detection limit in X-ray detection is defined as the equivalent dose rate to produce a photocurrent greater than three times the noise current (dark current). <sup>c</sup> TPC extracted: speed here can be defined as the time at which the photocurrent decays from the peak to the original 1/e extracted from the transient photocurrent curves.



Fig. 7 (a) Schematic diagram of the internal phase arrangement process and the corresponding charge transportation in MHP thin films. (b) The top and bottom PL spectra of different phase arrangement films. Reproduced with permission.<sup>56</sup> Copyright 2023, Elsevier. (c) Schematic illustration of the selfassembled 2D–3D MHPs obtained by an ion-exchange-induced crystallization method. (d) PL spectra monitoring of different 2D–3D MHP combinations.57 Reproduced with permission. Copyright 2022, Elsevier.

PL spectra monitoring helped unveil the effect of halide anions  $(Br^{-}$  and  $I^{-})$  on crystal formation in these thick MHP films (Fig. 7d). The resulting 2D–3D MHP thick film-based devices exhibited extremely low  $J_{\rm d}$  (0.8 nA cm $^{-2}$ ), an ultra-fast speed of 640 ns, and a detection limit of 4.2  $nGy_{air}$   $s^{-1}$ . Furthermore, they demonstrated a prototype 1024-pixel detector array for Xray imaging. The strategies and the corresponding device structures and performance parameters are summarized in Table 2. These advancements in engineering the dimensional and phase distribution of MHPs hold great promise for achieving high-performance and stable MHPPDs.

### 5.3 Additive engineering and the modulation of crystallization methods

Being an ionic crystal, the occurrence of anion/cation vacancies within the bulk and at the interface of MHPs is inevitable

during the thin film formation process. To address this, a passivation technique involving the addition of additives in the bulk and at the interface of MHPs has been developed. This technique creates coordinating bonding, eliminates vacancies, and fills interstitial spaces, ultimately leading to a reduction in  $J<sub>d</sub>$  of the MHPPDs. We have summarized the progress in MHPPDs achieved through the application of relevant additive engineering for both the bulk and interface of MHPs in Table 3.

For instance, Wang et al. devised a moisture-triggered additive, poly(vinyl alcohol) (PVA), to passivate surface defects in FAPbI<sub>3</sub>.<sup>104</sup> Their results demonstrate that the PVA organic framework fills the grain boundaries of  $FAPbI<sub>3</sub>$ , thereby stabilizing the favorable black phase of  $FAPbI<sub>3</sub>$  and guarding against moisture intrusion through strong interactions with water molecules. The PVA-passivated  $FAPbI<sub>3</sub>$  films also exhibit self-healing capabilities upon bending, activated by water

#### Table 2 Summary of the dimensional engineering in MHPs for suppressing  $J<sub>d</sub>$  and enhancing the FOMs of MHPPDs



TPC extracted: speed here can be defined as the time at which the photocurrent decays from the peak to the original 1/e extracted from the transient photocurrent curves. <sup>b</sup> Detection limit: the detection limit in X-ray detection is defined as the equivalent dose rate to produce a photocurrent greater than three times the noise current (dark current).  $^c$  Noise signal: the noise signal in photodetection is recorded by utilizing a fast Fourier transform signal analyzer combined with a preamplifier to capture the noise current at various frequencies. <sup>d</sup> Drifting: drifting means the dark current drift period D.

molecules (Fig. 8a). Ionic liquids serve as promising candidates for bulk defect passivation in MHPs due to their diverse controllable sources of anions and cations. Gao et al. showcased the effectiveness of 1-butyl-2,3-dimethylimidazolium chloride (BMIMCl) in passivating defects within CsSnI<sub>3</sub> NWbased films.<sup>95</sup> Their study revealed that BMIMCl exerts a potent passivating effect on Sn-related defects through the large  $\pi$ bonds in N–C $=N$ , enhancing electron density around  $Sn^{2+}$  in  $CSSnI<sub>3</sub>$  and shielding it from oxidation to  $Sn<sup>4+</sup>$ . By combining polymethyl methacrylate (PMMA) for bulk defect passivation in  $CSSnI<sub>3</sub>$  NW-based films, the CsSnI<sub>3</sub>-based MHPPDs demonstrated reduced  $J_d$  and highly stable behavior (Fig. 8b).

Thiocyanate salts are recognized as effective additives for controlling the crystallization process and delaying oxidation through strong interactions with metal cations. Liu and colleagues investigated the impact of multifunctional tin thiocyanate  $(Sn(SCN)_2)$  additives on Sn-Pb MHPs.<sup>100</sup> Their addition of the additive to the Sn–Pb MHP precursor led to a preferred doublesided surface distribution within the MHP film, effectively reducing Sn oxidation levels (Fig. 8c). Subsequently, they achieved a high  $D^*$  (8.48  $\times$  10<sup>12</sup> Jones at 910 nm) and outstanding stability (lifetime of 2300 h) in NIR MHPPDs. Effective additives in the bulk of quasi-2D MHPs can regulate the 3D MHP phase within quasi-2D MHP films. Di et al. introduced



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frequencies. <sup>b</sup> TPC extracted: speed here can be defined as the time at which the photocurrent decays from the peak to the original 1/e extracted from the transient photocurrent curves. Detection limit: the detection limit in X-ray detection is defined as the equivalent dose rate to produce a photocurrent greater than three times the noise current (dark current).



Fig. 8 (a) The mechanism of protection and self-healing process by PVA in FAPbI<sub>3</sub> films. Reproduced with permission.<sup>104</sup> Copyright 2021, Wiley-VCH. (b) MHPPD based on the CsSnI<sub>3</sub> with BMIMCI additive and photo/dark current. Reproduced with permission.<sup>95</sup> Copyright 2022, Nature. (c) Sn 3d XPS spectra of the pure Sn–Pb and Sn(SCN)<sub>2</sub> Sn–Pb films. Reproduced with permission.<sup>100</sup> Copyright 2023, ACS. (d) XRD patterns and UV-vis absorption spectra of the control and with CBH quasi-2D MHP films. Reproduced with permission.<sup>82</sup> Copyright 2023, Wiley-VCH.

carbohydrazide (CBH) additives into quasi-2D (PEA)<sub>2</sub>MA<sub>3</sub>Pb<sub>4</sub>I<sub>13</sub> precursors, resulting in significantly improved crystallinity and alignment of the 3D phase.<sup>82</sup> This enhancement was evident in sharper XRD diffraction peaks and a higher ratio of the 3D MHP phase in quasi-2D MHP films, impacting their absorption characteristics (Fig. 8d).

In addition to incorporating additives in the bulk and at the interface of MHPs to passivate defects and regulate phase distribution, researchers have explored modifications to fabrication and crystallization methods to achieve the same objectives. For instance, Bao and colleagues synthesized thin single crystals of MHPs using space confinement methods to significantly reduce bulk defect density and eliminate grain boundaries in polycrystalline MHPs. $^{74}$  As depicted in Fig. 9a and b, the synthesized thin single crystals of  $MAPbBr<sub>3</sub>$  and  $MAPbI<sub>3</sub>$ exhibited excellent X-ray diffraction patterns with [100] orientation growth, and thermal admittance spectroscopy revealed a low trap state density. The resulting MHPPDs based on these thin single crystals demonstrated low noise currents of 1-2 fA Hz<sup>1/2</sup> and ultra-low sub-pW  $cm^{-2}$  weak light detection limits. In a separate study, Zhu and colleagues introduced room-temperature crystallization in a Sn-rich binary MHP system to achieve compact and smooth Sn–Pb MHP thin films.<sup>72</sup> By utilizing the strong Sn–O ionic bond between  $SnI_2$ and dimethyl sulfoxide (DMSO), as well as the Sn–I ionic bonding between MAI and  $SnI<sub>2</sub>$ , the Sn-rich binary MHP precursor films could crystallize at room temperature and transform into black and smooth films after antisolvent treatment and the annealing process (Fig. 9c). These resulting thin films were successfully demonstrated on metal–oxide–semiconductor substrates, and the MHPPDs based on this method exhibited a large LDR of 100 dB and a fast speed of 2.27 µs. Wang and colleagues developed a modified two-step spin-coating method for producing large grain size and pinhole-free Pb-based MHP thin films.<sup>90</sup> In the modified step, MAI was intercalated with  $PbI<sub>2</sub>$  on the surface to form an intermediate phase, which was then transformed into the desired polycrystalline MHP film after thermal annealing (Fig. 9d). By optimizing the concentration of MAI in the MAI: $PbI_2$  mixture, the target thin film could be achieved (Fig. 9e). The resulting P–I–N MHPPDs based on this MHP thin film exhibited the lowest  $J_d$  of 5.55  $\times$  $10^{-4}$  mA cm<sup>-2</sup>, as well as a fast speed of 2.6 µs and 72.8 µs. Furthermore, researchers have also minimized bulk defects in MHPs through the fabrication of thick MHP films using thermal evaporation methods $73$  and the production of MHP QD films through spray-coating methods.<sup>71</sup>

#### 5.4 Engineering of the MHP/CTL interfaces

It is important to note that shallow-energy defects can transform into deep traps in MHP films, leading to performance degradation and instability in devices. Near the surface of MHPs, the density of deep traps is significantly higher, ranging from one to two orders of magnitude greater than in the bulk. Surface defects in MHPs, including A-site, B-site, and X-site vacancies, as well as B-site antisite substitutions, are primarily responsible for the presence of surface or buried defect states. These states contribute to detrimental leakage current and the rapid degradation of MHPPDs. Moreover, the energy level



Fig. 9 (a) XRD patterns of MAPbBr<sub>3</sub> and b) MAPbI<sub>3</sub> single-crystals obtained from the 2D X-ray diffraction patterns. Insets are the 2D X-ray diffraction patterns along with the photographs of the single crystals. (b) Trap-density-of-states curves of devices based on MAPbBr<sub>3</sub> and MAPbI<sub>3</sub> single-crystals. Reproduced with permission.<sup>74</sup> Copyright 2017, Wiley-VCH. (c) Schematic illustrations of the bonding between SnI<sub>2</sub> and DMSO, and the bonding between SnI<sub>2</sub> and MAI, along with the crystallization process of the Sn–Pb films. Reproduced with permission.<sup>72</sup> Copyright 2019, ACS. (d) Modified twostep spin-coating method for producing high-quality MAPbI<sub>3</sub> films. (e) Absorption curves and optical images of the various MAI concentrations are conducted in the second step. Reproduced with permission.<sup>90</sup> Copyright 2022, RSC.

alignment and charge extraction at the interface play a crucial role in determining the device's overall performance. Therefore, effective interface engineering between MHPs and CTLs is crucial for passivating these defects and establishing a cascade architecture, ultimately reducing  $J_d$  in MHPPDs.

The importance of interface engineering in MHPPDs differs from that in photovoltaic devices based on MHPs with a common structure involving a mesoporous oxide/MHP heterojunction or a planar architecture utilizing thin CTLs. In MHPbased photovoltaics, the large effective junction area results in a substantial parasitic capacitance, leading to slow speed and current leakage due to the presence of large crystallites in the thin film. To address this issue, Lin and colleagues achieved high-performance MHPPDs by incorporating relatively thick double fullerene hole blocking layers (HBLs)  $[PC_{60}BM/C_{60}]$ . This design effectively reduced the shunt capacitance, enabling ultra-fast photo-response and suppressing current leakage by creating a large hole injection barrier.<sup>105</sup> Similarly, Fang et al. employed a cross-linked hole-transporting layer, N4,N4'-bis(4-(6-((3-ethyloxetan-3-yl)methoxy)hexyl)phenyl)-N4,N4-diphenylbiphenyl-4,4'-diamine (OTPD) (Fig. 10a), and controlled the thickness

of the C<sub>60</sub> layer to suppress  $J_d$  (9.1  $\times$  10<sup>-9</sup> A cm<sup>-2</sup> at -2 V) and noise current (5.5 fA  $Hz^{-1/2}$  at  $-0.1$  V) in MHPPDs.<sup>10</sup> In another study reported by Bao and co-workers, polyethyleneimine ethoxylate (PEIE) was introduced as a substrate modifier for long-term stable inorganic MHPPDs. This modification resulted in ultra-fast MHPPDs with a speed of 602 ns to 20 ns for CsPbIBr<sub>2</sub> and CsPbBr<sub>3</sub> (Fig. 10b) over various active areas.<sup>106</sup>

In addition to organic interface layers, inorganic oxide layers deposited using atomic layer deposition (ALD) show promise for suppressing  $J_d$  and enabling ultra-fast MHPPDs. Cen et al. utilized ALD to fabricate CsPbBr<sub>3</sub>-based MHPPDs with  $Al_2O_3$ and TiO<sub>2</sub> interfacial layers<sup>107</sup> (Fig. 10c). These layers significantly reduced current leakage by more than three orders of magnitude, leading to the successful realization of robust visible light communication systems. The investigation of organic CTLs for MHPPDs in X-ray detection has also been explored. Demchyshyn and co-workers employed PCBM and PTCDI as the HBL and PEDOT:PSS and  $NiO<sub>x</sub>$  as the hole transport layer in a P–I–N MHPPD structure using  $(Cs_{0.05}(FA_{0.83}MA_{0.17})_{0.95}PbI_{3-x}Br_x)$  as the high energy photon absorption layer.<sup>108</sup> The results demonstrated different



Fig. 10 (a) Energy diagram of the cross-linked OTPD MHPPDs. Reproduced with permission.<sup>10</sup> Copyright 2015, Wiley-VCH. (b) Transient response curves of the inorganic MHPPDs with PTAA/PEIE. Reproduced with permission.<sup>106</sup> Copyright 2018, Wiley-VCH. (c) Energy band diagram of the MHPPDs with ultrathin Al<sub>2</sub>O<sub>3</sub> and TiO<sub>2</sub> modification layers. Reproduced with permission.<sup>107</sup> Copyright 2019, Wiley-VCH. (d) Summary of the interface engineering based on several organic materials. Reproduced with permission.<sup>108</sup> Copyright 2020, Wiley-VCH. (e) XRD patterns of quasi-2D thin films without and with PEDOT:PSS interlayer (left), the insets are the corresponding top-view FESEM images (scale bar: 1 µm), and schematic illustration of the orientational growth of MHP films without/with PEDOT:PSS interlayer. Reproduced with permission.<sup>109</sup> Copyright 2023, Wiley-VCH.

performance characteristics for different configurations, with the lowest  $J_{\rm d}$  (0.030  $\pm$  0.004 nA cm<sup>-2</sup>) achieved in the NiO<sub>x</sub>/ MHP/PCBM/BCP configuration and the lowest detection limit  $(0.58 \pm 0.05~\mu\text{Gy s}^{-1})$  in the PEDOT/MHP/PCBM/TiO<sub>x</sub> configuration. (Fig. 10d) Furthermore, Zhang et al. investigated the importance of PEDOT:PSS and  $PC_{71}$ BM in quasi-2D PEA<sub>2-</sub>  $MA<sub>3</sub>Pb<sub>4</sub>I<sub>13</sub>$ -based MHPPDs for UV-A region detection.<sup>109</sup> The inclusion of PEDOT:PSS as the substrate enhanced the vertical orientation of  $PEA_2MA_3Pb_4I_{13}$ , as indicated by a smoother XRD pattern. (Fig. 10e) The uniform crystalline morphology and gradient phase distribution of quasi-2D MHPPDs obtained here exhibit a respectable  $D^*$  of 1.3  $\times$  10<sup>12</sup> Jones, along with a swift speed of 313  $\mu$ s/40.8 ms. Furthermore, extensive efforts have been directed towards introducing new CTLs and modifying both organic and inorganic CTLs to effectively passivate surface defects, construct cascades, and suppress  $J<sub>d</sub>$ , thereby enhancing the performance of MHPPDs, as outlined in Table 4.

#### 5.5 Heterojunctions

Forming heterojunctions with MHPs, either by using MHPs themselves or other semiconductors with superior

optoelectronic properties, offers significant advantages. These heterojunctions suppress unwanted current leakage by constructing P–N junctions and enhance device performance in several ways. They expand the photoresponse range by incorporating additional photoresponsive materials and improve stability by protecting the MHPs. Zhang et al. demonstrated a solution-based epitaxial method for the controlled fabrication of MHP single crystal heterojunctions, including MAPbBr<sub>3</sub>/ MAPbI<sub>3</sub> and MAPbCl<sub>3</sub>/MAPbBr<sub>3</sub> heterojunctions.<sup>148</sup> The epitaxial growth process is illustrated in Fig. 11a. By analyzing the PL properties of different locations along the cross-section of the MHP single crystal heterojunction, the researchers confirmed the controllable gradual conversion from  $p$ -type (MAPbI<sub>3</sub>) to ntype (MAPbBr<sub>3</sub>) characteristics (Fig. 11b). The high-quality MHP single crystal heterojunctions with a gradient energy band structure at the heterointerface (Fig. 11b) enabled the optimized MHPPDs to achieve low detection limits for direct X-ray detection and minimal  $J<sub>d</sub>$  drift. Likewise, Liu and colleagues employed an epitaxial method through vapor-phase deposition to establish a monocrystalline CsPbBr<sub>3</sub> (p-type)–SrTiO<sub>3</sub> (n-type) halide-oxide perovskite P–N heterojunction, as depicted in







Table 4 (continued) continued) Table 4 (



 Noise signal: the noise signal in photodetection is recorded by utilizing a fast Fourier transform signal analyzer combined with a preamplifier to capture the noise current at various frequencies.  $^b$  TPC extracted: speed here can be defined as the time at which the photocurrent decays from the peak to the original 1/e extracted from the transient photocurrent curves. r Noise signai: me noise signai in photodetection is recorded by utunzing a rast rourier transform signal analyzer compined with a preampinier to capture the noise current at various frequencies. <sup>A</sup> TPC extracted: speed h Detection limit: the detection limit in X-ray detection is defined as the equivalent dose rate to produce a photocurrent greater than three times the noise current (dark current).

Fig.  $11c$ .<sup>149</sup> The inclusion of rigid SrTiO<sub>3</sub> not only increased device stability by preventing anion interdiffusion between  $CsPbBr<sub>3</sub>$  and  $SrTiO<sub>3</sub>$ , leading to an effective operating temperature of 150  $\degree$ C for the MHPPD, but also facilitated the formation of a sharp P–N interface with  $CsPbBr_3$ , ensuring low  $J_d$  and satisfactory photoresponse. Furthermore, Wang et al. demonstrated a P-I-N heterojunction (n-type, Bi-doped MAPbBr<sub>3</sub>)/ (intrinsic,  $\text{MAPbBr}_{2.5}\text{Cl}_{0.5}$ )/(p-type, Ag-doped  $\text{MAPbBr}_3$ ) by a solution-processed dopant incorporated epitaxial growth method.<sup>150</sup> To identify suitable dopants, researchers investigated the thermal-probe-induced effects of MHPs incorporating different dopants. After optimization, 0.1 M AgBr-doped and 0.2 M Bi-doped MAPbB $r_3$  were grown on opposite faces of the  $MAPbBr<sub>2.5</sub>Cl<sub>0.5</sub>$  substrate to form a P-I-N heterojunction (Fig. 11d). Benefiting from the efficient P–I–N junction, which provides sufficient charge barriers and facilitates energy alignment, the MHPPDs exhibited a low  $J_d$  of 11 nA  $cm^{-2}$  under 500 V cm<sup>-1</sup> and a lowest detection limit of 16 nGy  $s^{-1}$ . More recently, Zou and colleagues developed a dual-band heterojunction configuration of MAPbBr<sub>3</sub>/PCBM/FASn<sub>0.5</sub>Pb<sub>0.5</sub>I<sub>3</sub> using a high-throughput blading method for ultra-fast MHz imaging and communication speeds (Fig. 11e). $151$  This dual-band heterojunction, benefiting from the absorption of both wide  $(MAPbBr<sub>3</sub>)$  and narrow  $(FASn<sub>0.5</sub>Pb<sub>0.5</sub>I<sub>3</sub>)$  MHPs and tuning of the polarity and amplitude of the bias voltage, enabled MHPPDs based on this structure to achieve a  $D^*$  of 1.25/3.10  $\times$   $10^{12}$  Jones and bandwidths of 16.5/>20 MHz for the visible/ NIR bands. Published on the state of the interaction and Materials chemistry contributed on the state of the policies and contributed on 12/24. The state of the state

Additionally, researchers have developed MHP heterojunctions incorporating narrow band gap ionic dyes (Fig. 12a) and QDs (Fig. 12b) to extend light absorption deep into NIR regimes and effectively suppress device  $J_d$  through precise gradient energy alignment design.152,153 For the UV regime of the heterojunction in MHPPDs, Ga<sub>2</sub>O<sub>3</sub> (Fig. 12c) and ZnO (Fig. 12d) were employed to achieve efficient carrier separation and broaden the photoresponse of MHPPDs.<sup>154,155</sup> Table 5 compares the performance parameters of recent MHPPDs based on various heterojunctions.

### 5.6 Architecture modification

The device architecture plays a crucial role in reducing  $J_{\rm d}$  and enhancing the FOMs of MHPPDs. By controlling the stacking type of materials, manipulating the electrodes, and incorporating extra devices into the MHPPDs, it is possible to efficiently mitigate  $J_d$  and increase the FOMs of MHPPDs. For example, Song et al. designed lateral P–I–N single crystal MHPPDs to isolate the electrodes from contacting the MHP surface, in contrast to conventional metal–semiconductor–metal photodiodes, as illustrated in Fig. 13a.<sup>180</sup> The resulting devices exhibited nearly three orders of magnitude suppression of  $J_d$ compared to the metal–semiconductor–metal devices. Moreover, they demonstrated environmental stability by avoiding the interfacial electrochemical reaction between the electrode and MHP. In another approach, Jin et al. developed a MHPPD architecture by adding a shunting electrode as a blanking unit to suppress  $J_d$ .<sup>181</sup> As depicted in Fig. 13b, electrons are emitted



Fig. 11 (a) Epitaxial growth process of the MHP heterojunction. (b) Positions for PL measurements (left), PL spectra (middle), and band diagram of the MHP heterojunction without bias (right). Reproduced with permission.<sup>148</sup> Copyright 2023, Wiley-VCH. (c) Schematic diagram of the vapor-phase epitaxy of the CsPbBr<sub>3</sub> thin film on halide–oxide perovskite. Reproduced with permission.<sup>149</sup> Copyright 2023, Wiley-VCH. (d) Energy diagram and the fabrication process of the MHP heterojunction by doping in the epitaxial growth. Reproduced with permission.150 Copyright 2021, Elsevier. (e) Optoelectronic properties of the double MHP heterojunction thin films. Reproduced with permission.<sup>151</sup> Copyright 2024, Wiley-VCH.

from the source to the drain electrode with two lateral terminals in the dark. To minimize the absolute value of  $I<sub>d</sub>$ , a top dark-current-shunting electrode on the MHP films was utilized to attract the emitted electrons, leading to effective shunting of mobile electrons under dark conditions. This design resulted in an ultra-low $J_{\rm d}$  of 51.1 pA cm $^{-2}$  and a detection limit of 7.84 nGy  $s^{-1}$ . Additionally, Zhan *et al.* introduced a modification to the device structure by presenting a MHPPDs crossbar array through vapor deposition.<sup>182</sup> This array consisted of a P-I-N diode (ITO/PEDOT:PSS/MHP/PCBM/BCP) and a reverse blocking diode (PCBM/BCP/PbI2/Spiro-TTB) in a vertically stacking sequence, with PCBM/BCP serving as the co-cathode, as shown in Fig. 13c. The presence of the blocking diode established an efficient barrier to prevent electron transfer to the Ag electrode. This configuration is fully scalable and compatible with integrated circuits, making it suitable for the industrialization of image sensors. The devices and the corresponding strategies for architecture modification and performance parameters are summarized in Table 6.

### 6. Summary and perspectives

Due to their remarkable optical and electrical properties, MHPPDs have showcased unparalleled performance, surpassing commercially available inorganic counterparts in recent years. In addition, formidable progress has been made in developing robust optoelectronic applications such as static

imaging for visible and X-ray spectra, $141,186$  real-time dynamic imaging, $182$  communications, $102,107$  and health monitoring.<sup>91,187</sup> Despite this, MHPPDs still face challenges related to defects within their structure that impair the dynamics of charge carriers, diminishing photodetection performance metrics like  $J<sub>d</sub>$ , LDR,  $D^*$ , and speed. To address these issues, a deep understanding of  $J_d$ 's origin in MHPPDs is critical. Research has been directed towards component and dimensional engineering to mitigate defects within the bulk and interfaces, interfacial engineering, the integration of heterojunctions, and adjustments to device architectures. Tables 1–6 encapsulate the enhancements in  $J_d$  and other FOMs demonstrated using these strategies. Future research targeting superior performance and durability in optoelectronic devices, facilitating detection across a broad spectral range from ionizing radiation to near-infrared, is indispensable. Achieving high EQE or  $R$  while simultaneously suppressing the  $J<sub>d</sub>$  in MHPPDs is critical and challenging. Both EQE (or  $R$ ) and  $J_d$  are highly dependent on carrier generation, extraction, and recombination processes. The efficiency of these processes directly impacts EQE (or  $R$ ) and  $J<sub>d</sub>$ . For instance, the quality of the MHP films and the interfaces between the MHP and the EBL as well as the HBL are essential for influencing charge transportation and recombination, thereby impacting EQE (or  $R$ ) and  $J<sub>d</sub>$ . The mobility and stability of the EBL and HBL are highly relevant to charge extraction and recombination at the interface between MHP and EBL/HBL, thereby also affecting EQE (or  $R$ )



Fig. 12 (a) Photoresponse of the CyPF<sub>6</sub>, Cy<sub>1</sub>BF<sub>4</sub>, and MHP-CyPF<sub>6</sub>, Cy<sub>1</sub>BF<sub>4</sub> heterojunction MHPPDs. Reproduced with permission.<sup>152</sup> Copyright 2017, Wiley-VCH. (b) Energy band diagram of the MHP/CuInSe<sub>2</sub> QDs heterojunction (left), the absorption and PL spectra of the MHP/CuInSe<sub>2</sub> QD thin film (right). Reproduced with permission.<sup>156</sup> Copyright 2020, Wiley-VCH. (c) Absorption spectrum and bandgap of MAPbCl<sub>3</sub> and amorphous  $Ga_2O_3$ films (left), the I-t curves of the MAPbCl<sub>3</sub>/amorphous Ga<sub>2</sub>O<sub>3</sub>-based devices (right). Reproduced with permission.<sup>157</sup> Copyright 2022, Elsevier. (d) Energy band diagram showing the band alignment and carrier dynamics of the CsSnI<sub>6</sub>/ZnO device under different biases. Reproduced with permission.<sup>155</sup> Copyright 2020, RSC.

and  $J<sub>d</sub>$ . Furthermore, mechanical stress at the interface between MHP and EBL/HBL can introduce defects that deteriorate EQE (or  $R$ ) and  $J<sub>d</sub>$ . Therefore, by employing advanced passivation techniques, improved fabrication methods, and optimized device architectures aimed at increasing the quality of the MHP film, EBL/HBL, and the interface between MHP and EBL/HBL, it is possible to develop MHPPDs with high EQE (or  $R$ ) and low  $J_d$ .

Central to advancing MHPPDs is an in-depth understanding of the origins of  $J<sub>d</sub>$ . Current research predominantly employs the conventional semiconductor-based photodiode model grounded in thermodynamics. However, given MHPs' ionic characteristics, it is pivotal to develop a nuanced MHPPD model accounting for ion migration within the bulk and interfaces—an imperative for light sensing and direct radiation detection applications. A comprehensive model must also incorporate interactions between MHPs, CTLs, and electrodes to thoroughly describe charge carrier behavior under dark conditions.

Addressing the defects present in MHPs is the crucial strategy for substantially reducing the  $J_d$  in MHPPDs. These defects, located in the bulk and at the interfaces of MHPs, are recognized as major contributors to elevated  $J<sub>d</sub>$  levels and undesirable periods of  $J_d$  drift in MHPPDs. Thankfully, numerous effective strategies have emerged which include component, additive, and interfacial engineering. Among these, strategic component selection is particularly promising in mitigating issues such as ion migration and phase transitions caused by these defects. Monovalent cations like FA are highly competitive in MHPs used in MHPPDs for broadband light detection, owing to their lower bandgap and improved thermal and light stability compared to other cations. Similarly, the choice of halide ions plays a critical role. Beyond just tuning the absorption spectrum of the devices, previous studies have highlighted the beneficial effects of various halide anions on the crystallization process and defect suppression in MHP films. Notably,  $Cl^-$  and bromine  $Br^-$  ions, at certain concentrations, can enhance crystallinity, morphology, and stability of MHPs, which in turn boosts photodetection performance.

Passivation techniques involving additives in MHP precursor solutions and interfacial engineering are critical for defect suppression and overall device performance enhancement. It is imperative to develop thoughtful additive design strategies and more resilient CTLs that consider the multifunctional effects of additives and the complexities of surface defect configurations. Moreover, there is a need for continued research into strategies for constructing heterojunctions either with MHPs or with other superior optoelectronic materials. These heterojunctions could help in managing surface defects, aligning energy bands, and improving optoelectronic properties, thus potentially mitigating  $J_d$  and minimizing periods of  $J_d$  drift in MHPPDs.

Further rethinking of the architecture of MHPPDs can serve to effectively suppress  $J_d$ . Introducing additional layers, such as EBL or HBL, can prevent charge carriers from being injected from the electrodes into the MHP, thereby reducing  $J<sub>d</sub>$ . The alignment of material energy levels, as well as both vertical and lateral architectural designs, are crucial in influencing the charge dynamics within the device. Additionally, the implementation of electrical regulation methods can effectively curb  $J_d$  and further diminish  $J_d$  drift periods.<sup>181,188</sup> Future research should focus on simplifying device structures and developing strategies suitable for large-scale industrial production.

Controlling the operational temperature of MHPPDs has shown potential in minimizing  $J_d$  and enhancing device performance. Lower temperatures effectively restrain thermal excitation of charge carriers, thereby reducing  $J_{\text{diff}}$  generation. This temperature-dependent suppression offers promising prospects for achieving enhanced  $D^*$  in MHPPDs. Moreover, operating at cooler temperatures can increase the stability and lifespan of MHP films by curbing degradation processes. However, maintaining an optimal temperature is essential; excessively low temperatures may impair the device's response time and sensitivity. Therefore, it is critical to finely tune the





 $\text{MAPbBr}_3/\text{Au}$ 







Fig. 13 (a) The schematic diagram, the energy level diagram, and dark current curves of the metal–semiconductor–metal (MSM) and lateral P–I–N devices. Reproduced with permission.<sup>180</sup> Copyright 2021, Wiley-VCH. (b) The schematic illustration of the conventional and dark-current-shunting MHPPD under dark and X-ray radiation. Reproduced with permission.<sup>181</sup> Copyright 2023, Nature. (c) The structure of an integrated PIN-blocking diode. (d) Current–voltage (I–V) curves of the blocking diode. Reproduced with permission.<sup>182</sup> Copyright 2022, Wiley-VCH.

temperature range to strike a balance between suppressing  $J_d$ while sustaining overall device effectiveness.

Additionally, thorough testing and accurate characterization of MHPPDs are imperative.<sup>189</sup> Common issues include the overestimation of  $D^*$  due to the oversight of noise currents other than  $J_{\mathbf{d}}$ ,  $^{190}$  the challenges in testing MHPPDs for direct Xray detection under atmospheric conditions,<sup>191</sup> and incorrect application of formulas or linear fitting in assessing the LDR of MHPPDs.<sup>192</sup> Implementing advanced characterization techniques is fundamental to elucidate the chemical, morphological, structural, and optoelectronic attributes of MHPs, which assist in mitigating  $J_d$  in MHPPDs. Techniques such as UV-visible-NIR spectroscopy, photoluminescence (PL), time-resolved PL, and transient absorption spectroscopy are instrumental in directly assessing the light absorption and luminescence properties of MHPs. Electron microscopies like scanning electron microscopy (SEM), transmission electron microscopy (TEM), atomic force microscopy (AFM) combined with conductive AFM (c-AFM), and energy-dispersive X-ray (EDX) spectroscopy provide in-depth analysis of chemical, morphological, and structural properties at the interface of MHPs. Depth-profiling techniques, including X-ray photoelectron spectroscopy (XPS) and time-of-flight secondary ion mass spectrometry (TOF-SIMS), are crucial for profiling the chemical composition through the depth of MHPs. Characterization techniques geared towards electrical properties, such as electrochemical impedance spectroscopy (EIS), space-charge-limited currents, and transient photovoltage/photocurrent studies, are critical for investigating charge transport and extraction dynamics in MHPPDs. By leveraging these advanced techniques and refining the associated methodologies, we can better differentiate the performance attributes of MHPs, address their intrinsic challenges, and drive forward the performance of MHPPDs. In conclusion, as research continues to focus on suppressing  $J_d$ 



Summary of the architecture modification in MHPs for suppressing  $J_d$  and enhancing the FOMs of MHPPDs anaza modification in MHDs for مسيممة مامس Cummanus of the Table 6



Detection limit: the detection limit in X-ray detection is defined as the equivalent dose rate to produce a photocurrent greater than three times the noise current (dark current).

and improving the reliability and functionality of MHPPDs, their practical application in the field of optoelectronics is becoming increasingly feasible.

## Author contributions

Yue Wang, D. Li, and Q. Song conducted the literature review and drafted the manuscript. Yue Wang, D. Li, Yang Wang, Y. Chen contributed to manuscript editing and grammar check. Yue Wang, D. Li, Q. Song, Y. Liu, Yang Wang and Y. Chen secured funding, resources, supervision, and contributed to manuscript editing.

## Data availability

No primary research results, software or codes have been included and no new data were generated or analysed as part of this review.

# Conflicts of interest

There are no conflicts to declare.

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